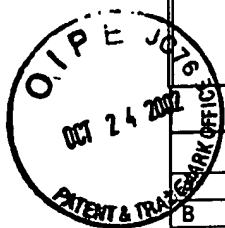




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U.S. PATENT DOCUMENTS					
	EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	FILING DATE
A	AQ	6,138,185	10/24/00	Nelson et al.	10/29/98
B	AQ	6,148,004	11/14/00	Nelson et al.	02/11/98
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FOREIGN PATENT DOCUMENTS					
	EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	Translation
U					
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U.S. PATENT DOCUMENTS							
	EXAMINER'S INITIALS	PATENT NO.	DATE	NAME	CLASS	SUBCLASS	FILING DATE
A	AQ	5,974,467	10-26-99	Haddock et al.	709	240	02-27-98
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FOREIGN PATENT DOCUMENTS							
	EXAMINER'S INITIALS	PATENT NO.	DATE	COUNTRY	CLASS	SUBCLASS	Translation
U	AQ	0 856 969	08-05-98	EP			
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